

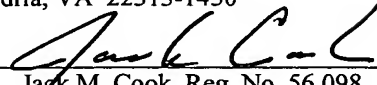
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PATENT

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Date of Signature and Deposit: December 23, 2005


Jack M. Cook, Reg. No. 56,098

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No.: 10/675,642
Filed: September 30, 2003
Applicant(s): Herbert, Patrick C., et al.
Title: Microelectromechanical Strain Gauge
Art Unit: 2855
Examiner: Ellington, Alandra
Docket No.: 02AB062

**INTERVIEW SUMMARY AND REQUEST FOR RECONSIDERATION AFTER
FINAL OFFICE ACTION**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Final Office Action dated November 2, 2005, please find the following Interview Summary and Request for Reconsideration After Final in light of the interview between the undersigned and Examiner Noori.

A listing of the Claims begins on page 2 of this communication.

An Interview Summary and Request for Reconsideration begins on page 11 of this communication.